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Piyush Dak

Purdue University, Birck Nanotechnology Center, piyushjdak@gmail.com

Aida Ebrahimi

Purdue University, Birck Nanotechnology Center, sebrahim@purdue.edu

Muhammad A. Alam

Purdue University, Birck Nanotechnology Center, alam@purdue.edu

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Non-Faradaic Impedance Characterization of an

Evaporating Droplet for Microfluidic and Biosensing

Applications¹

Piyush Dak¹⁻², Aida Ebrahimi¹⁻², and Muhammad A. Alam^{1-2*}

1. School of Electrical and Computer Engineering, Purdue University, West Lafayette, IN 47907,

USA

2. Birck Nanotechnology Center, Purdue University, West Lafayette, IN 47907, USA

* Author to whom correspondence should be addressed: <u>alam@ecn.purdue.edu</u>

† The code for droplet impedance model can be downloaded from

https://engineering.purdue.edu/~alamgrp/dak_files/droplet_impedance.zip

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ABSTRACT:

We develop a general numerical/analytic theory of non-faradaic impedance of an evaporating droplet, and

validate the model by experiments involving droplets of various analyte concentrations deposited on a

surface defined by coplanar electrodes. The impedance of the droplet $Z(n_0, t, f)$ is analyzed as a function

of concentration (n_0) of the ions in the solution, the measurement frequency (f) and the evaporation time

(t). We illustrate the versatility of the model by determining the sensitivity enhancement $\alpha(t)$ of the

droplet-based impedimetric nano-biosensor under different regimes of operation. The model should have

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broad applications in characterization/optimization of droplet-based systems, especially lab-on-chip components involving digital microfluidics.

Introduction:

Droplets occur in broad range of natural and engineered systems. In natural systems, for example, a drop of water on a lotus leaf forms a spherical shape to minimize the surface energy¹. When a drop of liquid with suspended particles dries on a substrate, it leaves a ring-shaped stain on the surface generally known as the "coffee-ring effect²⁻⁴". On the other hand, in the engineered systems, micro/nano-liter sized droplets have been used in broad range of applications including drop-on-demand inkjet printing⁵, molecule transport⁶, single-cell analysis and sorting⁷ through microfluidic channels, electrically-addressable biochemical reactions in sub-nanoliter droplets⁸, etc. Evaporating droplets have also found a number of interesting applications. Jing *et al.* have used tiny evaporating droplets to elongate and fix DNA molecules on derivatized surfaces⁹; De Angelis *et al.* have reported attomolar-detection of DNA concentration by concentrating few copies of DNA to a localized SPR sensor by evaporation of droplet¹⁰; and most recently Ebrahimi *et al.* have reported a label-free on-chip non-faradaic impedance based detection of attomolar (aM) concentration of DNA¹¹. The concentration of biomolecules was enhanced through evaporation of the droplet and an enhanced signal was obtained for even a few copies of DNA in micro-liter sized droplets.

Optical techniques such as high-speed imaging¹², confocal microscopy¹³ and laser light scattering^{14,15} have been used to characterize the geometry and composition of droplets. For probing the dynamics of droplet on a surface, an electrical characterization technique such as impedance spectroscopy can provide complementary information. In this regard, it is desirable to have a theoretical model which can map the system parameters like the droplet composition, shape and size to an electrical signal (i.e. impedance) as the droplet evaporates. Faradaic impedimetric sensors¹⁶ have long been used for highly selective detection of biomolecules. If the analyte is known and only its concentration is desired, non-Faradaic Impedance spectroscopy (NFIS) provides a simpler non-intrusive way to provide wealth of information regarding the

composition of the droplet and the kinetics of evaporation. Important initial work on NFIS has already been reported. For example, Sadeghi *et al.* performed on-chip impedance based droplet characterization for a parallel plate electrode system¹⁷. For a broader range of applications, however, all droplet models must be generalized to include accumulation of ionic charges (double layer) near the electrode surface, arbitrary geometry of electrodes, the time dynamics and droplet shape dependence of impedance components, and all the parasitic components."

In this paper, we formulate a comprehensive theory for droplet impedance with focus on nano-biosensing⁹
11. We solve for the time dynamics of droplet evaporation and relate the composition, size and shape of the droplet to the time-varying impedance. We demonstrate that the approach can be used in optimization of the sensor design and operate the sensor in optimal frequency range. Indeed, the model is general and can be used in a broad range of microfluidic systems.

The paper is arranged as follows. In section 1, we describe the device structure and operation principle of the droplet based sensor. In section 2.1, we describe the impedance/admittance response of the system for a fixed droplet geometry. In section 2.2, we describe the time dynamics of droplet evaporation and describe the geometry variation as a function of time. In section 2.3, we provide the time dependence of circuit components/impedance for the system. In section 3.1 and 3.2, we explain the sensitivity enhancement of the droplet based sensor in various operation regimes and discuss the implications of parasitic impedance respectively. Finally, the model is validated with the experiments on droplets containing DNA molecules in section 3.3.

1. Device structure and Principle of operation:

As a model system for the theoretical framework, we consider an evaporating droplet containing chemical/biomolecules resting on a substrate with co-planar electrodes, as shown in Fig. 1(a) and (b). We assume that the surface is designed in such a way that the droplet is pinned and maintains constant contact line as it evaporates¹¹. The contact width (r) and the contact angle (θ) that the droplet makes with the

surface depends on the surface wettability and the droplet volume. The electrical impedance of the droplet is measured by applying a small ac signal (with a dc bias) between the electrodes. The impedance of the droplet, $Z_{drop}(n_0, f, t)$, depends on the time-dependent (t) shape of the droplet, the initial concentration of ions (n_0) , and the characterization frequency (f). As the droplet evaporates, Z_{drop} changes due to two distinct but correlated effects: the increase in ionic concentration associated with decrease in the droplet volume, and the change of the droplet geometry due to evaporation. The changes in Z_{drop} can be used as a characterization tool for many droplet-based problems and applications discussed earlier. For droplet-based nanobiosensors, the positive implications are obvious (see Fig. 1(b)): the shrinking droplet brings the analyte biomolecules close to the sensor surface faster than the diffusion limit¹⁸. As a result, the concentration of the biomolecules increases inversely with the volume of the droplet and this increased concentration is reflected in enhanced sensitivity¹⁹, S(t) defined as change in conductance $(\Delta Y(t))$ with respect to known reference solution (DI water).

For simplicity, we assume that the droplet is self-aligned to coplanar electrodes, as shown in Fig. 1(b). The conclusions of the paper, however, are general and would apply to any electrode geometry. The electrodes are multi-functional: they define the superhydrophobic surface that pins the droplet and can also be used as an addressable heater. If the electrodes are simultaneously used as heater and prober, a complex interaction is likely. Therefore, for simplicity of model development, we use the electrodes exclusively for impedance measurement, and the heating effects are not considered. The applied voltage is presumed small to suppress the Faradaic current²⁰. However, if a higher applied voltage is necessary for application under consideration, electrodes maybe coated with a thin dielectric layer to block any charge transfer between the electrode and the solution (refer to Supplementary Information 3 for implications).

Finally, the substrate offers a parasitic path for signal to travel between the electrodes (see, Fig. 1(b)) and thereby defines the upper limit for the frequency of operation. At high enough frequencies, the impedance of the overall system, Z_{net} is dictated by the parasitic impedance, Z_{par} and becomes insensitive to the properties of the droplet itself. Depending on the substrate (e.g. glass vs. silicon-on-insulator, SOI), the

parasitic impedance may change by orders of magnitude; therefore, the choice of the substrate is important in defining the sensitivity of the sensor.

2. Numerical/Compact modeling of droplet impedance:

2.1. Frequency response of the droplet impedance

Let us first consider the frequency dependence of impedance of a droplet (see Fig. 1(a)) with constant contact angle θ resting on a substrate with two planar electrodes. For an arbitrary electrode (faradaic/non-faradaic), the different components which can affect the impedance are shown in Fig. 1(c). Here, R_{ct} denotes the charge transfer resistance²⁰, Z_w the Warburg impedance²¹, C_{dl} double layer capacitance, R_{series} denotes resistance of the solution and C_{geo} the dielectric (geometric) capacitance of the droplet. The net impedance of the system is therefore given by

$$Z_{net} = (R_{series} + 2 Z_{dl}) || \left(\frac{1}{j\omega C_{geo}}\right) || \left(Z_{par}\right), \tag{1}$$

where $Z_{dl} = (R_{ct} + Z_w) || \left(\frac{1}{j\omega C_{dl}}\right)$ represents the double layer impedance and Z_{par} the parasitic impedance.

For a non-faradaic electrode, there is no charge transfer at the surface, so that $R_{ct} \to \infty$ and hence the net impedance of the system simplifies to

$$Z_{net} \approx \left(R_{series} + \frac{2}{j\omega C_{dl}}\right) ||\left(\frac{1}{j\omega C_{geo}}\right)||\left(Z_{par}\right)$$
 (2)

The rest of the paper will focus on this reduced 'non-faradaic' model with the understanding that it can be easily generalized to include Faradaic contributions as well.

Physically, R_{series} originates from the finite conductivity of the solution, σ as $R_{series} = g H_z / \sigma$ where $g = g(\theta, r, W, L)$, which we call geometry factor. This factor depends on the width (W), separation (L) between the electrodes and droplet contact angle θ and contact width r. H_z represents the length of cylindrical segment as shown in Fig. 1(a). The conductivity σ can be related to the ionic concentration (n_i)

as $\sigma = qn_i(\mu_p + \mu_n)$ where μ_p and μ_n are respectively the ionic mobilities of the positive and negative ions in the solution.

Similarly, the geometry capacitance which depends on the permittivity of the solution (ϵ) and the same geometry factor, g as in R_{series} (refer to Supplementary Section 1) can be written as $C_{geo} = H_z \epsilon/g$. Henceforth, unless explicitly specified, we assume that the analyte concentration is small so that $\epsilon \approx \epsilon_{fluid}$ and is unaffected by the salt/analyte concentration.

Finally, C_{dl} originates from the adsorbed charge layer and diffuse layer charge²² and can be written $C_{dl} = \left(\frac{1}{c_S} + \frac{1}{c_{diff}}\right)^{-1}$ where C_S is the Stern capacitance²³ and C_{diff} is called the differential capacitance. For electrode separation/droplet dimensions much larger than the debye length ($\lambda_d \sim 1~\mu m$ for pure water), the diffuse layer capacitance can be described by analytic formula $C_{diff} = A\sqrt{\frac{2q^2\epsilon\,n_l}{kT}}\,\cosh\left(\frac{qV_e}{2kT}\right)$ where $A = rH_Z$ is the area of the electrode in contact with the solution and V_e is the applied bias on the electrode, q the electronic charge, k the boltzman constant, and T temperature of the solution. While applicability of this analytic formula is well established for bulk solutions²², we show through detailed numerical simulations (refer to Supplementary Section 1 (b)) that this can also be applied to micro-liter sized droplets. For medium to low ionic concentrations (< 100~mM), Debye length is much larger than the thickness of the Stern layer ($\sim 0.4~nm$)²⁴ so that $C_{diff} \ll C_S$ and hence, $C_{dl} \approx C_{diff}$.

Once the droplet/electrode geometry are specified, the fluid properties are given $(e.g. \ \epsilon_{fluid})$, and the salt (n_0) /analyte concentrations (ρ) is known, Z_{drop} is fully determined, and can be plotted, among other variables, as a function of frequency f.

Frequency response of an ideal system with no parasitic losses can be divided into three distinct regions (see, Fig. 2(a)), such that impedance components R_{series} , C_{dl} and C_{geo} are dominant in each of these three regions. For $f < f_{low} = \frac{2}{2\pi R_{series} C_{dl}}$, C_{dl} dominates the net impedance, for $f_{low} < f < f_{high} = \frac{2}{2\pi R_{series} C_{dl}}$

 $\frac{1}{2\pi R_{series}\, C_{geo}}$, R_{series} is the dominant component, and finally for $f > f_{high}$, C_{geo} dominates. The numerical/analytic estimation of different circuit components and cut-off frequencies is described in Supplementary Section 1 and 2, respectively. For a conductivity based sensor, we should be operating in either regime I or II, while detection can be done in the regime III if the change in permittivity of the solution upon addition of biomolecules is considerable.

The admittance of the droplet (see Fig. 2(b)) is defined as $Y_{drop} = 1/Z_{drop}$. We can define the limit of detection as the minimum measurable change in conductance ΔY_{drop} of the droplet upon introduction of salt/biomolecule.

In order to improve the limit of detection several design parameters can be considered, *i.e.* electrode separation (L), electrode width (W), electrode length (H_z) in contact with droplet. These factors have considered by Hong *et al.* albeit with a bulk solution. The higher the electrode length and the smaller the electrode spacing, the better is the sensitivity²⁵. However, for ultra-small concentration of biomolecules, the diffusion of the ions limits the detection time. Therefore, in order to improve the sensitivity and response time of the system, we need to explore droplet volume (V) (or contact angle (θ)) as an additional design parameter. This can be achieved by evaporation of the droplet which is considered next.

2.2. Dynamics of droplet evaporation

Droplet forms as a result of balance of surface tensions at the triple contact line between air, liquid and surrounding medium. Equivalently, the shape of the droplet can be determined by energy minimization²⁶. Our earlier work¹¹ showed that the droplet placed on nanotextured-superhydrophobic electrodes assumes a nearly ellipsoidal shape with pinned contact lines at the edges of the droplet. Contact line pinning of droplet is critical for highly stable impedance characterization. A constant contact width for evaporating droplet is also obtainable using chemically heterogeneous striped surface²⁷.

In order to determine the time evolution of impedance of such a pinned droplet, we must first determine the evolution of droplet shape with time. Numerical calculations show and high-speed images confirm that as

the droplet evaporates, it maintains the shape of an elongated ellipsoid, defined by a constant contact width r and decreasing perpendicular (θ_{\perp}) and parallel (θ_{\parallel}) contact angles¹¹. For analytic simplicity, we will approximate the elongated ellipsoid as a truncated cylinder with contact width r and contact angle θ , while keeping all other constraints (e.g. initial volume) unaltered, see Fig. 1(b). Our model is directly applicable in scenarios where the elongation of the droplet parallel to the coplanar electrodes is large as compared to that in direction perpendicular to the electrodes. However, the 'cylindrical' approximation is not restrictive – the formulation is general and can be applied to any system where the evolution of droplet shape (*i.e.* the geometry factor, g(t)) and droplet volume (V(t)) is known through numerical simulation²⁸ or high-speed imaging¹².

Similar to Rowan *et al.*²⁹ and Birdi *et al.*³⁰, we consider droplet evaporation as a gas diffusion process and assume that the rate of mass loss from droplet is given by $\Phi_m = \int \vec{J} . d\vec{S}$ where \vec{J} is the diffusion flux of liquid molecules away from the surface and integral of the flux is taken over the surface of the droplet. The diffusion flux can be written in terms of the concentration of liquid vapors $(c(r,\theta,z))$ as $\vec{J} = -D\vec{\nabla}c$ where D is the diffusion coefficient of liquid vapors in the ambient surroundings. Therefore, the rate of mass loss would be, $\Phi_m = -\int_{\Omega} D\vec{\nabla}c . d\vec{S}$. In order to evaluate this integral, we use the equivalence between the electric potential (ψ) and vapor concentration (c) as discussed in Supplementary Section 4. For an electrical system, we can write charge $Q = -\int \epsilon \nabla \psi . d\vec{S} = C_e(\psi_s - \psi_\infty)$ where C_e is the electrical capacitance. Similarly, the diffusion flux of molecules can be written as $\Phi_m = C_D$ ($C_S - C_\infty$) where C_S is the saturation vapor density of liquid and C_∞ is the vapor density of liquid far away from surface. C_D is the diffusion equivalent capacitance of a truncated cylinder with finite length Φ_S which is given by,

$$C_D = \frac{2\pi D H_z}{\alpha} \left(1 + \frac{0.3069}{\alpha} + \frac{0.2717}{\alpha^2} \right) \frac{\theta}{\pi}$$
 (3)

where $\alpha = \log\left(\frac{H_z}{R_s}\right)$ where R_s is the radius of curvature of the droplet. Note, that the diffusion equivalent capacitance of the cylinder with finite length has been appropriately scaled for reduced surface area of the

truncated cylinder. If we assume that the density of liquid is constant as the droplet evaporates, the rate of mass loss can be expressed as,

$$\Phi_m = -\frac{dm}{dt} = -P\frac{dV}{dt},\tag{4}$$

where P is the density of liquid, m is the mass of droplet, V is the volume of liquid for a given contact angle and t is time.

Therefore,

$$P\frac{dV}{dt} = -C_D(c_S - c_\infty)$$
 (5)

For simplicity, we assume that the evaporation occurs at a constant temperature so that c_s is independent of time. Also, the equation assumes that the evaporation from the front and back surfaces of the cylinder is negligible, which is justified as long as $H_z \gg r$. Once we relate V and R_s to the contact angle θ (see, Supplementary Table 4), the rate of change of contact angle as a function of θ is given by,

$$\frac{d\theta}{dt} = -\frac{D(c_s - c_\infty)}{P r^2} \frac{(\theta \sin^2 \theta)}{1 - \theta \cot \theta} \left(1 + \frac{0.3069}{\alpha} + \frac{0.2717}{\alpha^2} \right) \frac{1}{\alpha} = -\lambda f(\theta, r, H_z)$$
(6)

where $\lambda = \frac{D(c_s - c_\infty)}{P}$ captures the material parameters of the droplet. This equation can be numerically integrated to obtain $\theta(t)$ and V(t). Fig. 3 shows the evolution of droplet contact angle (θ) and volume (V) as a function of time (t). Simulation parameters are listed in Supplementary Table 2 and 3. Interestingly, despite the complexity of the equation, one finds that the volume evolution of the droplet can often be described by a power-low 33

$$V(t) = V_0 \left(1 - \frac{t}{\tau}\right)^n \tag{7}$$

where τ and n are empirical parameters defined by the shape of the droplet and the mode of the evaporation. For the experimental data obtained from Ebrahimi *et al.*¹¹, we find that the parameter n = 3/2 and $\tau = 20$ *min*.

2.3. <u>Time evolution of impedance/conductance:</u>

The net impedance of the droplet is given by

$$Z_{drop}(\omega, t) = \left(R_{series}(t) + \frac{2}{j\omega C_{dl}(t)}\right) || \left(\frac{1}{j\omega C_{geo}(t)}\right)$$
 (8)

Given the geometry dependence of the circuit components and time dependence of geometry, we can determine the time dependence of different circuit components as follows:

1. Series Resistance/Conductance: Variation in series resistance due to evaporation comes from two distinct effects. First, the geometry factor $g(r,\theta)$ evolves with $\theta(t)$, so that $g(t) = g(\theta(t))$, see Fig. 3 and SFig. 1(b). Second, the concentration of the ions in the solution increases inversely with the volume of the evaporating droplet, V(t). If the electrolyte composing the droplet solution is fully ionized, we can assume that conductivity is directly proportional to the ionic concentration. Therefore, the conductivity $\sigma(t) = \sigma_0 V_0/V(t)$ increases as a function of time. At any time, series resistance is given by,

$$R_{series} = \frac{g(t)}{\sigma(t) H_z} = \frac{g(t)V(t)}{\sigma_0 H_z V_0} = R_0 \frac{g(t)}{g_0} \frac{V(t)}{V_0}$$

$$\tag{9}$$

where R_0 represents the resistance of the solution at time t = 0 and $g_0 = g(t = 0)$.

Here, V_0 and σ_0 are the initial volume and conductivity of the droplet, respectively. Fig. 4(a) shows the evolution of R_{series} and $G_{series} \equiv R_{series}^{-1}$ as a function of time.

2. <u>Double Layer Capacitance</u>: The increased concentration of the evaporating droplet is also reflected in C_{DL} , as follows: Since, the concentration at any time t is given by $n_i(t) = n_0 V_0 / V(t)$, the double layer capacitance would be,

$$C_{DL}(t) = A \sqrt{\frac{2q^2 \epsilon \, n_i(t)}{kT}} \, \cosh\left(\frac{qV_e}{2kT}\right) = C_{DL,0} \sqrt{\frac{V_0}{V(t)}}$$
(10)

where $C_{DL,0}$ is the double layer capacitance at t=0. Fig. 4(b) shows the evolution of the double layer capacitance as a function of time.

3. Geometry Capacitance: The geometry (dielectric) capacitance C_{geo} = H_z ε/g(t) is independent of the ion concentration (any dependence can come through only permittivity of the solution, ε), but depends on the geometry of the droplet through g(t). The variation of C_{geo} as a function of time is shown in Fig. 4(b). Our numerical simulations show that both g(θ) and θ(t) are monotonically decreasing functions of θ (SFig. 1 (b)) and t (Fig. 3) respectively; therefore g(t) is monotonically increasing function of time t. Therefore, the geometry capacitance decreases with time unlike G_{series} and C_{DL}.
To summarize, the impedance evolution is specified by two parameters, g(r,θ(t)) and V(t)/V₀. Once these two parameters are known either from experiments, or detailed numerical models such as surface evolver²⁸; or by approximate analytical/numerical model discussed above, one can compute any electrical characteristics associated with evaporating droplets. In the next section, we will illustrate the concept by analyzing a droplet-based sensor.

3. Application of model to a droplet based sensor:

3.1 Frequency-dependent time response of Biosensors:

Our earlier work showed that a droplet based sensor has improved sensitivity over sensors based on bulk liquid¹¹. In order to determine the relative improvement in sensitivity, we define sensitivity of the droplet-based sensor as normalized change in admittance of droplet containing analyte (Y_{ρ}) with respect to a reference solution i.e. DI water (Y_{DI}) . Therefore,

$$S(t) = \left| \frac{Y_{\rho}(t) - Y_{DI}(t)}{Y_{DI}(t=0)} \right| = \alpha(t) \times \left| \frac{Y_{\rho}(t=0) - Y_{DI}(t=0)}{Y_{DI}(t=0)} \right|$$
(11)

a) Low frequency operation:

In this range of frequency $f \ll f_{low}(t)$ for all 0 < t < T, the double layer capacitance is the dominant component i.e. $Y(t) \sim j\omega C_{dl}(t)$. As the droplet shrinks and the concentration increases, the reduction in the double layer thickness is reflected in increasing C_{dl} . The sensitivity of this mode of operation can be defined as the change in the double layer capacitance upon addition of chemical/biomolecule $(C_{dl,\rho})$ with respect to a reference solution (DI water) $(C_{dl,DI})$. Using Eq. 11 with $Y(t) = j\omega C_{dl}(t)$, sensitivity is given by

$$S(t) \sim \frac{C_{dl,\rho}(t) - C_{dl,DI}(t)}{C_{dl,DI}(t=0)} = \frac{\Delta C_{dl,\rho}}{C_{dl,DI}(t=0)}$$
(12)

The amplification in sensitivity relative to time t=0 is obtained by inserting Eq. 10 in Eq. 12 i.e.

$$\alpha(t) = \sqrt{\frac{V_0}{V(t)}} \approx \frac{1}{\left(1 - \frac{t}{T}\right)^{\frac{n}{2}}}$$
(13)

where we have used the empirical approximation of $V(t)/V_0$ from Eq. 7. Note that the amplification factor is independent of the contact angle of the droplet at any time. Fig. 5(a) shows the sensitivity and amplification factor for very low frequency mode of operation of a sensor with initial ion concentration $n_0 = 10 \ \mu M$.

b) Intermediate frequency operation: This regime of operation occurs when $f_{low}(t) \ll f \ll f_{high}(t)$, and therefore $Y(t) \sim G_{series}(t)$. In this regime, the capacitive response of the ions is no longer relevant and the in-phase response of the ions with respect to the applied signal dictates the net impedance. The sensitivity S(t) in this regime of operation can be defined in terms of the conductance change upon addition of chemical/biomolecule (G_0) with reference to DI water (G_{DI}) , *i.e*

$$S(t) = \frac{G_{\rho}(t) - G_{DI}(t)}{G_{DI}(t=0)} = \alpha(t) \frac{\Delta G_0(t=0)}{G_{DI}(t=0)}$$
(14)

where $\Delta G_0 = G_{\rho}(t=0) - G_{DI}(t=0)$ and the amplification factor,

$$\alpha(t) \approx \frac{g_0}{g(t)} \times \frac{V_0}{V(t)} \sim \frac{1}{\left(1 - \frac{t}{\tau}\right)^n}$$
 (15)

relates the sensitivity enhancement obtained as a function of time. Note that even though, g(t) is monotonically increasing as a function of time, the net amplification factor $(\alpha(t))$ still increases due to considerable reduction in droplet volume V(t). This equation suggests that a very high sensitivity can be achieved if we operate the sensor in a frequency regime where G_{series} is dominant. Fig. 5(b) shows the sensitivity and amplification factor for intermediate frequency mode of operation of a sensor with initial ion concentration $n_0 = 10 \, \mu M$.

c) <u>High frequency operation</u>: This regime occurs when $f \gg f_{high}(t)$, so that $Y(t) \sim j\omega C_{geo}(t)$. Again the sensitivity of the system can be defined as

$$S(t) = \frac{C_{geo,\rho}(t) - C_{geo,DI}(t)}{C_{geo,DI}(t=0)} = \alpha(t) \frac{\Delta C_{geo,\rho}(t=0)}{C_{geo,DI}(t=0)}$$
(16)

where $C_{geo,\rho}$ and $C_{geo,DI}$ are respectively the geometry capacitances for the droplet with chemical/biomolecules and the reference solution (DI water). The amplification in sensitivity relative to time t=0, is given by

$$\alpha(t) = \frac{g_0}{g(t)} \tag{17}$$

Since g(t) is a monotonically increasing function of time, the sensitivity in this regime of operation degrades with time i.e. $\alpha(t) \leq 1$. Fig. 5(c) shows the evolution of sensitivity (S(t)) and amplification factor ($\alpha(t)$) as a function of time. It is assumed that the permittivity change of the solution upon addition of chemical/biomolecules is 10%.

Further, for a conductance based sensor (with negligible change in solution permittivity), $\Delta C_{geo,\rho} = 0$ and hence this regime is unsuitable for biomolecule detection. However, if one is interested in characterizing the time-dependent evolution of the geometry of the droplet (e.g. shape or volume), this frequency regime is ideally suited, since the impedance is independent of salt/analyte concentration and depends exclusively on droplet geometry.

In general, as the droplet evaporates, the relative importance of a particular circuit component changes as well. This is because the cut-off frequencies, $f_{low}(t) = \frac{1}{2\pi R_{series}(t)C_{dl}(t)}$ and $f_{high}(t) = \frac{1}{2\pi R_{series}(t)C_{geo}(t)}$, themselves evolve with time; as the boundaries of the frequency band shift, the circuit may become more resistive/capacitive at a given frequency of operation. Fig. 5(d) shows the evolution of lower and upper cutoff frequencies for a droplet containing salt solution with initial concentration $n_0 = 10 \,\mu M$. Given the time and frequency dependence as discussed in section 2.3, one can determine the frequency of operation for which $\Delta Y(t)$ is maximum for a given set of parameters, such as mobility of ions (μ) and applied bias (V_e). For example, in case μ of ions is large, it would be preferable to operate the sensor in resistive regime for optimal sensitivity. For such an operation, a frequency choice, $f_{optimal}$ such that

$$10 \max(f_{low}) \le f_{optimal} \le \min\left(\frac{f_{high}}{10}\right)$$

would be appropriate, since this will ensure that the resistive component at any time is at least 10 times larger than the capacitive component. When the applied bias is large, so that double layer capacitance is significant, a frequency of operation $f_{optimal} \leq 10 \min(f_{low})$ would ascertain the operation in capacitive regime. However, a very large applied bias may not be desirable because it would yield unreasonably low frequencies for capacitive operation and lead to faradaic currents²⁰ that can contaminate results of impedance spectroscopy. For a more realistic case, when substrate parasitic capacitance must be accounted for (discussed in next section), the upper cut-off frequency is given by $f_{high}(t) = \frac{1}{2\pi R_{series}(t)(c_{par}+c_{geo}(t))}$. This implies that $\frac{1}{2\pi R_{series}(t)}$ the upper cut-off frequency can be substantially lower if the parasitic capacitance (C_{par}) is large. If $10 \max(f_{low}) \geq \min(f_{high}/10)$, it is impossible to operate the sensor in dominantly resistive regime and the parasitic capacitance must be suppressed to increase f_{high} .

3.2 Implications of parasitic impedance of the substrate, Z_{par}

So far, we have focused exclusively on Z_{drop} , assuming that the parasitic capacitance/resistance of the substrate is negligible. However, in real systems the parasitic capacitance can be a major limitation to the sensitivity of the device and must be accounted for. Parasitic capacitance dominates at intermediate to high frequencies and can limit frequency range of operation of the sensor. It can either be obtained from experiments with droplet-free measurements¹¹ or through detailed numerical simulation/analytic modeling. Here, we consider numerical/analytic evaluation of parasitic capacitance for two different substrates which are commonly used for impedance-based sensors:

1. Glass as the sensor substrate: Due to its low dielectric constant, glass is an ideal candidate for use as a substrate for the sensor. The parasitic capacitance is estimated by numerical simulation of the structure shown in Fig. 6(a) using Sentaurus, an advanced multidimensional device simulator³⁴. A bias V_{dc} is applied between the electrodes and Laplace equation $(\nabla \cdot (\epsilon_{glass} \phi) = 0)$ is solved to determine the potential, ϕ and electric field, E inside the substrate. Charge Q_{dc} is estimated on the positive electrode

by Gauss Law *i.e.* $Q_{dc} = \int_{\Omega} \vec{D} \cdot d\vec{S} = \int_{\Omega} \epsilon_{glass} \vec{E} \cdot d\vec{S}$. The capacitance of the substrate is then given by $C_{par} = Q_{dc}/V_{dc}$. An analytic expression for capacitance of coplanar electrodes was derived by Wei³⁵, *i.e.*

$$C_{par} = \frac{\epsilon_{ox} H_E}{2 K(k) / K(\sqrt{1 - k^2})}$$
(18)

where K(k) is the complete elliptical integral of first kind with k = L/(L+W), ϵ_{glass} denotes the permittivity of glass substrate and H_E is the electrode length.

Fig. 6(b) and 6(c) show the simulation (numerical/analytic) of the parasitic capacitance for different electrode separations (width = 900 μ m) and for different electrode width (separation = 20 μ m). The capacitance is very weakly dependent on the electrode separation and width. Numerical simulation is in good agreement with the analytic expression. The marginal difference in simulation and analytic estimate comes from the fact that Eq. 18 was derived by Wei neglecting the fringing fields in the transformed coordinate system.

2. **SOI** as the sensor substrate: The silicon-on-insulator (SOI) is a popular substrate in the semiconductor industry because it minimizes the leakage currents, radiation-induced photocurrents, latch-up effects, etc.³⁶ in comparison to conventional bulk substrates. However, the same leads to huge parasitic losses for impedance sensors, as the electrodes can couple to the doped silicon below the top oxide layer which leads to a large parasitic capacitance. Fig. 6(e) and 6(f) shows the numerical simulation results for parasitic capacitance of an SOI substrate (Fig. 6(d)) for different electrode separations (with width $W = 700 \ \mu m$) and different widths (with separation, $L = 20 \ \mu m$) respectively. The parasitic capacitance of SOI structure ($\sim 0.1 \ nF$) is nearly 3 orders of magnitude larger than that of the glass substrate

(\sim 0.1 *pF*). Also, the parasitic capacitance for the SOI substrate increases linearly with increase in the width of the electrodes.

A first order estimate of parasitic capacitance can be obtained by assuming the top silicon layer to be metal, so that net capacitance $C = \frac{WH_E \epsilon_{ox}}{2t_{ox}} = 0.97 \, nF$. However, since the top silicon layer has finite conductivity, the actual capacitance is smaller than the estimate which is observed in the simulation. Regardless, such a large parasitic coupling decreases $f_{high} \sim \frac{1}{2\pi R_{series}(C_{geo} + C_{par})}$ and confines the optimum sensor operation close to the low/intermediate frequency regimes¹¹.

If one must perform droplet characterization on SOI substrate at very high frequencies, a parallel plate detection system as described in Sadeghi *et al.*¹⁷ may be used. This will ensures that most of the electric field from the electrode is confined within the droplet resulting in lesser sensitivity to the substrate.

3.3 Experimental verification:

In order to validate the model described in the numerical section, both time and frequency response of droplets containing different DNA concentrations were analyzed. The data was obtained from Ebrahimi et al.¹¹. Frequency response of the system at t = 2 min was calibrated with the numerical model (see, Eq. 2) to determine the ionic conductivity (σ) for different DNA concentrations (see, Fig. 7(a), (b), (c))³⁷. Using this ionic conductivity (σ), the time response of the system was determined using $Z = Z_{droplet}(t)||Z_{par}(see, Eq. 8, Fig. 7 (d))$. Z_{par} was obtained from the droplet free measurement on the substrate¹¹. The ionic conduction was assumed to take place due to H^+ and OH^- ions as the experiments were performed using DI water containing DNA molecules. The DNA solution (purchased from Fermentas, Inc.) had 850 bp long synthetic molecules in 1xTAE buffer solution. The DNA molecules were precipitated using an isopropanol precipitation method and resuspended in nuclease-free DI water. Additional experimental details are provided in Ebrahimi et al.¹¹.

Despite of the various simplifying assumptions made in section 1, the model (solid lines) predictions agree with the experimental results (circles) remarkably well. Indeed, apart from fitting the t = 2 minconductivity at various analyte concentration, the model describes the time-evolution and frequency dependence of the droplet impedance consistently without any other fitting parameters. The key features of the experiments are reproduced: First, the model correctly estimates the frequency response of the system. At low frequency, the impedance is dependent on the composition of droplet (DNA) (compare, Fig. 7(a), (b) and (c)). At high frequency, the impedance of the parasitic substrate dominates and yields essentially same impedance for different DNA concentrations, making high frequency regime unsuitable for detection. Second, Fig. 7(d) shows that the time-evolution of the impedance predicted by the theoretical model correctly reproduces the features observed in the experiment. The impedance of the droplets with different DNA concentrations converge at higher times, due to decrease in droplet volume $(\Delta Z(t) \propto V(t)^{\eta}$, where $\eta \approx \frac{1}{2}$ or 1 depending on whether C_{dl} or R_{series} is dominant (refer Eq. 8, 9 and 10). Due to large parasitic capacitance, f_{high} varies in range 350 Hz - 960 Hz from t = 0 to t = 18 min respectively. This limits the operation of the device to sub-KHz range for sensing operation even at larger times. Additional results with phase plots that validates the robustness and accuracy of the model are presented in the Supplementary Section 4.

CONCLUSIONS

We have developed a comprehensive numerical and compact modeling framework for the impedance of an evaporating droplet. The model is simple, and yet the theoretical framework correctly predicts the complex, time-dependent electrical response of an evaporating droplet containing analyte molecules. Indeed, once the geometry factor g(t) and the volume evolution V(t) are determined, either through experiments or through numerical/analytic modeling, the response of the system is completely specified. As a result, this physics-based model can be used to optimize variety of droplet-related systems (e.g. the operation of a droplet-based sensor) once the system parameters, such as mobility of ions and applied bias, are specified. The model also highlights the critical importance of the substrate for highly sensitive impedance-based

chem-bio sensing. Specifically, for example, the model suggests that, compared to typical SOI substrate, the reduced parasitic impedance of a glass substrate would improve the overall sensitivity as well as provide a broader bandwidth of operation. Furthermore, higher frequencies can be used to characterize the droplet shape and size, since the impedance in that regime is independent of the droplet composition. If one must use SOI substrate for integration purposes, a comparable level of sensitivity is obtained only if the operating frequency is reduced to an extent that completely eliminates the effects of parasitic impedance on the overall impedance of the system.

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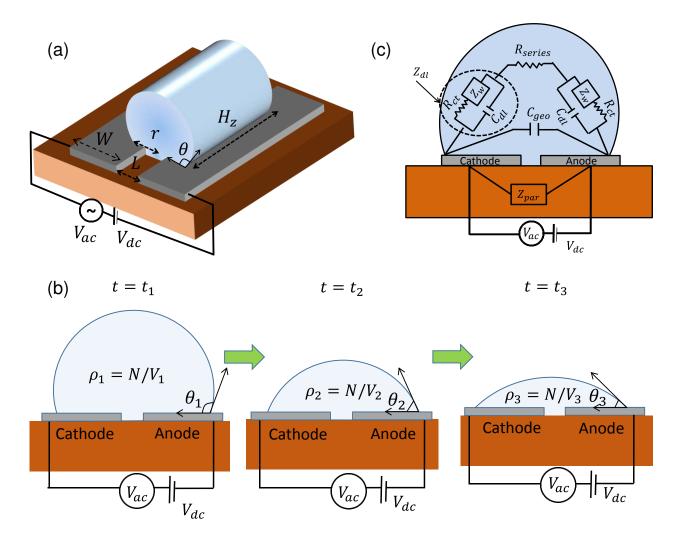


Fig. 1 (a) Model system for numerical/analytic modeling (b) Evaporation dynamics of droplet: As the droplet evaporates, the contact angle (θ) decreases while the contact line remains pinned. The concentration of the chemical/biomolecules (ρ) increases as the volume (V) decreases with time (t) with number of chemical/biomolecules (N) remaining constant (c) Equivalent circuit representation of the system.

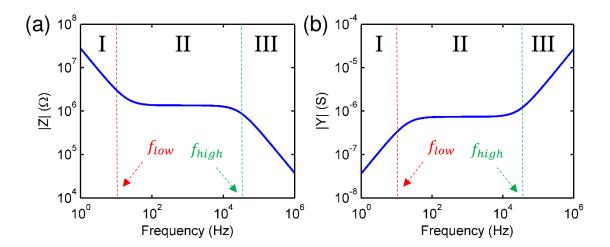


Fig. 2 (a) Impedance of the droplet as a function of frequency. C_{dl} dominates at $f < f_{low}$, R_{series} dominates for $f_{low} < f < f_{high}$ and C_{geo} dominates the impedance at very high frequency $(f > f_{high})$. Similar trend (2(b)) is visible in the admittance vs. frequency response.

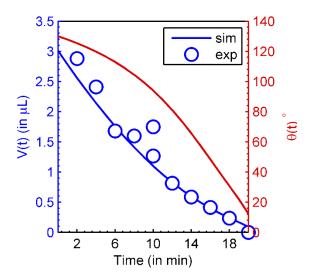


Fig. 3 Evolution of droplet contact angle (θ) (right) and droplet volume (V) (left) as a function of time. Symbols are the experimental data obtained from Ebrahimi et al¹¹. The variation of droplet volume as a function of time can analytically be approximated as $V = V_0 \left(1 - \frac{t}{\tau}\right)^n$ with n = 3/2 where V_0 is the initial volume of the droplet and τ the total evaporation time. Simulation Parameter: $(c_s - c_\infty)/c_s = 0.88$

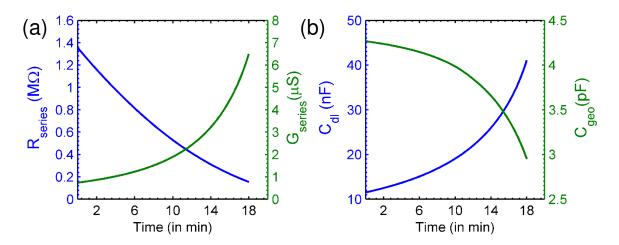


Fig. 4 (a) Time dependence of series resistance (left) and series conductance (right) (b) Time evolution of double layer capacitance (left) and Geometry capacitance (right) for $n_0 = 10 \ \mu M$ and $V_0 = 3 \ \mu L$.

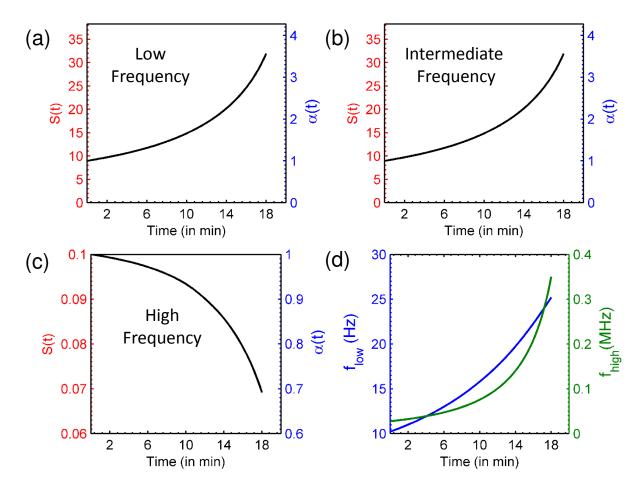


Fig. 5 Sensitivity as a function of evaporation time for (a) low frequency operation (b) intermediate frequency operation (c) high frequency operation (d) Evolution of cut-off frequencies as a function of time for $n_0 = 10 \ \mu M$ and $V_0 = 3 \ \mu L$.

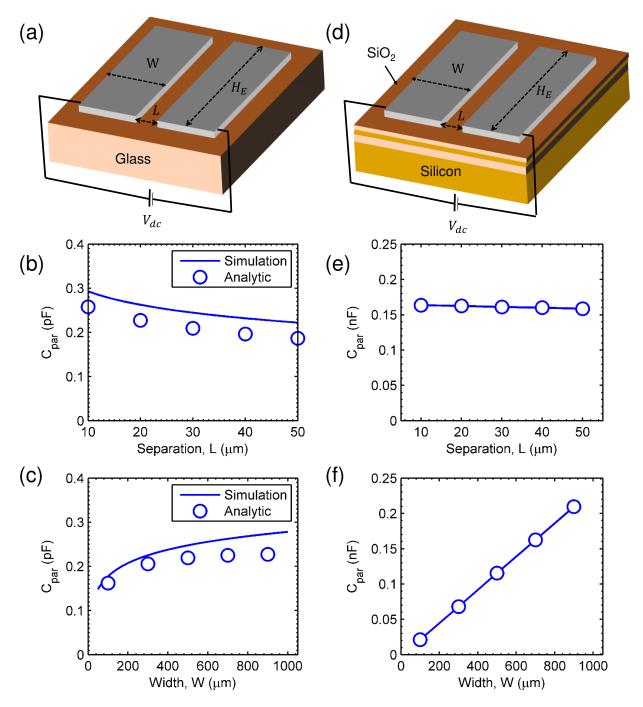


Fig. 6 Simulation of parasitic capacitance for two different substrates. Geometry used for the simulation for glass substrate (a) and SOI substrate (d). Variation of parasitic capacitance as a function of (b), (e) electrode separation and (c), (f) electrode width for glass and SOI substrate respectively.

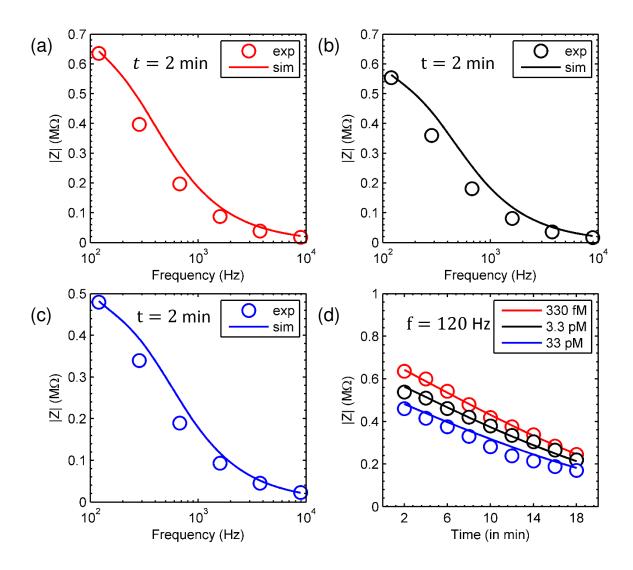


Fig. 7 Impedance vs. Frequency (calibration curves) at t = 2 min for different DNA concentration (a) 330 fM, (b) 3.3 pM and (c) 33 pM. (d) Impedance vs. Time for different DNA concentration: 330 fM (red), 3.3 pM (black) and 33 pM (blue). Lines and circles represent simulation and experiment respectively. Experimental data was taken from Ebrahimi *et al.*¹¹

Supplementary Information

Non-Faradaic Impedance Characterization of an

Evaporating Droplet for Microfluidic and Biosensing

Applications

Piyush Dak¹⁻², Aida Ebrahimi¹⁻², and Muhammad A. Alam^{1-2*}

- 3. School of Electrical and Computer Engineering, Purdue University, West Lafayette, IN 47907, USA
- 4. Birck Nanotechnology Center, Purdue University, West Lafayette, IN 47907, USA

S1. Geometry dependence of circuit components:

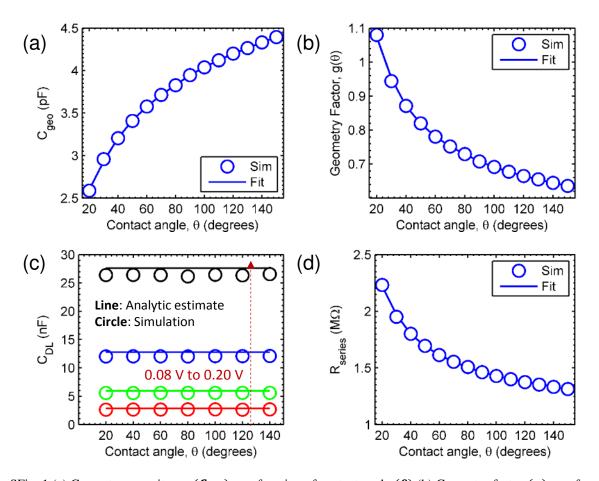
a) Geometric Capacitance $(C_{geo}(\theta))$: For a parallel plate system, the geometric (dielectric) capacitance is given by $C_{geo} = A\epsilon/d$ where A is the area of the electrodes, ϵ permittivity of the medium separating the electrodes and d the separation between the electrodes. This results from the solution of Poisson equation and is determined by the ratio of charge Q on the electrode and voltage V between the electrodes. For any given contact angle θ , the geometrical capacitance can be determined in similar way. We solve for the Poisson equation $(-\nabla \cdot (\epsilon \phi) = 0)$ within the droplet with the boundary condition $\phi = \pm V_e$ at the two electrodes using Sentaurus, An Advanced Device Simulator¹. The capacitance is given by $C_{geo} = Q/V_e = \int_{\Omega_e} \epsilon \vec{E} \cdot d\vec{S} / 2V_e$ where \vec{E} is the electric field at the surface of the electrode. Ω_e denotes the surface of the electrode. SFig. 1(a) shows the plot of the geometric capacitance as a function of contact angle θ of droplet with the surface.

^{*} Author to whom correspondence should be addressed: <u>alam@ecn.purdue.edu</u>

We can generalize this solution for any droplet size (H_z) in z direction, by defining $C_{geo} = H_z \, \epsilon/g(\theta)$ where $g(\theta)$ is dependent on the droplet shape. For a parallel plate capacitor, g = d/W where W is the width of the electrodes and d the separation between them. Geometry factor can be interpreted as $g = \frac{H_z \, V}{\int_{\Omega_e} \vec{E} \, d\vec{s}}$. SFig. 1 (b) shows the dependence of geometry function of the droplet contact angle (θ) . This definition of geometry factor would be useful in evaluation of series resistance which is discussed later. Note, that C_{geo} would be only impedance component of the droplet if it is non-conducting (which is dominant at high frequency when the ions don't respond to the ac signal). However, when electrolyte is conductive (at low/intermediate frequency), the solution will also have a double layer capacitance and series resistance which are discussed next.

b) Double Layer Capacitance ($C_{dt}(\theta)$): An electrode in contact with electrolyte forms a layer of surface ionic charge near its surface. This results in a formation of a diffuse layer due to columbic attraction to the surface charge. This double layer results in a net capacitance, $C_{dl} = \left(\frac{1}{C_S} + \frac{1}{C_{diff}}\right)^{-1}$ where C_S is called stern capacitance and C_{diff} is called the differential capacitance. If the debye length is much larger than the thickness of the stern layer than, $C_S \gg C_{diff}$, so that $C_{dl} \approx C_{diff}$. For any given contact angle θ , this capacitance, $C_{dl}(\theta)$ is evaluated by solving Poisson equation $-\nabla \cdot (\epsilon \nabla \phi) = \rho = p - n$ where p(x,y,z) and n(x,y,z) is the concentration of positive and negative ions in the solution respectively. Again, the capacitance is evaluated by evaluating the charge on the electrode, Q and differentiating it with respect to electrode voltage, V_e i.e. $C = dQ/dV_e$. SFig. 1(c) shows the variation of capacitance as a function of contact angle θ with $n_0 = 10^{-7}M$ for different applied biases. Also, shown is the plot of C_{dl} vs. θ from the analytic solution of Poisson equation in semi-infinite medium i.e. $C_{dl} = A\sqrt{2} \frac{q^2 \epsilon}{kT} \cosh\left(\frac{qV_e}{2kT}\right)^2$. The numerical solution is in excellent agreement with the analytic approximation. It can be concluded from the simulation that the double layer capacitance is independent of droplet geometry (different droplet shapes with same ionic concentration n_0). This is true as long as

the droplet dimensions are much larger than the Debye length $\lambda = \sqrt{\frac{\epsilon kT}{2n_0q^2}}$ in the ionic solution (maximum debye length is for pure water $n_0 = 100 \, nM$ i.e. $\lambda \approx 1 \, \mu m$). Finally, as the droplet evaporates the concentration of the electrolyte increases $n_i = n_i(\theta(t)) = n_0 \, V_0/V(\theta(t))$, which we have accounted for in Section 2.3.



SFig. 1 (a) Geometry capacitance (C_{geo}) as a function of contact angle (θ) (b) Geometry factor (g) as a function of contact angle (θ) (c) Double layer capacitance (C_{DL}) as a contact angle (θ) for different applied bias (V_e) i.e red 0.08 V, green 0.12 V, blue 0.16 V and black 0.20V (circles are from numerical simulation and lines are from analytic estimate) (d) Series resistance (R_{series}) as a function of contact angle (θ) for constant conductivity (σ)

Series Resistance $(R_{series}(\theta))$: Series resistance results from potential drop in the solution because of its finite resistivity. The resistance of a system with two parallel electrodes of area A separated by a distance d is given by $R_{series} = d/\sigma A$ where $\sigma = qn_i(\mu_n + \mu_p)$ is the conductivity of the solution.

This is result of solution of Poisson equation and evaluation of $R_{series} = \frac{V}{I} = \frac{V}{\int_{\Omega_e} \vec{J}.d\vec{s}}$ where $\vec{J} = \sigma \vec{E}$ is the current density. This can be related to the geometry factor that we defined earlier as $R_{series} = \frac{g(\theta)}{\sigma H_z}$. SFig. 1 (d) shows the series resistance dependence on the droplet contact angle (θ) .

The conductivity (σ) of the solution is assumed to be constant. Note that in addition to the change in series resistance due to geometry factor $g(\theta)$, there is an additional component $\sigma(\theta(t))$ that comes because of increase concentration of the solution as the droplet evaporates. This is accounted for in the estimation of resistance done in section 2.3.

S2. Description/Derivation of cut-off frequencies:

The net impedance of the system including for the parasitic impedance due to substrate is given by $Z_{net} = \left(R_{series} + \frac{2}{j\omega C_{dl}}\right) ||\left(\frac{1}{j\omega C_{geo}}\right)||\left(Z_{par}\right)$. When parasitic impedance can be represented by a simple capacitor i.e. $Z_{par} = \frac{1}{j\omega C_{par}}$, the net impedance simplifies to $Z_{net} = \left(R_{series} + \frac{2}{j\omega C_{dl}}\right) ||\left(\frac{1}{j\omega (C_{geo} + C_{par})}\right)$.

When double-layer capacitance is the dominant component in impedance, $\frac{2}{\omega C_{dl}} \gg R_{series}$ i.e. $\omega \ll \frac{2}{R_{series}C_{dl}}$. This gives the lower cut-off frequency, $f_{low} = \frac{2}{2\pi R_{series}C_{dl}}$. As f increases beyond f_{low} , R_{series} starts to dominate, so that $R_{series} + \frac{1}{j\omega C_{dl}} \approx R_{series}$. However, at high enough frequencies, $\frac{1}{\omega(C_{geo} + C_{par})} \ll R_{series}$, so that $Z_{net} \approx \frac{1}{j\omega(C_{geo} + C_{par})}$. This frequency is such that $\frac{1}{\omega(C_{geo} + C_{par})} \ll R_{series}$ i.e. $f_{high} = \frac{1}{2\pi R_{series}(C_{geo} + C_{par})}$. Intuitively, f_{low} and f_{high} represents frequencies at which the phase of $Z_{net} \approx -45^{\circ}$.

S3. Effect of dielectric layer covering electrodes:

In our analysis, we assumed that the dc bias across the electrodes is small so that the faradaic current components are negligible. However, if the device has to be operated at high dc biases in non-faradaic regime, we must cover the electrodes with dielectric coating to block any charge transfer between the electrode and the electrolyte. The effect of dielectric layer can effectively be incorporated in our model by putting a constant capacitor (impedance if the layer is conductive as well) in series with Z_{drop} at each of the electrode ends. For a dielectric layer of thickness t_{layer} , the capacitance of the dielectric layer is given by $C_{layer} = \frac{A \epsilon_{layer}}{t_{layer}}$ where ϵ_{layer} is the dielectric constant of the coating. The net impedance of the system is then given by $Z_{net} = \left(\frac{2}{j\omega C_{layer}} + \left(\left(R_{series} + \frac{2}{j\omega C_{dt}}\right)||\left(\frac{1}{j\omega C_{geo}}\right)\right)\right)|||Z_{par}||$. However, for physiological ionic concentrations (~100 mM), the double layer capacitance $C_{dl} \geq A \frac{\epsilon_w}{\lambda_d} \gg A \frac{\epsilon_{layer}}{t_{layer}}$. This is because $\lambda_d \sim 1nm$ (at 100 mM) and water has a very high dielectric constant as compared to dielectric coatings. This will deteriorate the sensitivity of the sensor at low frequency regimes since $Z_{net} \approx \frac{2}{j\omega C_{dt}} + \frac{2}{j\omega C_{layer}} \approx \frac{2}{j\omega C_{layer}}$ is independent of the droplet characteristics. Also, note that the double layer capacitance in this particular case is given by $C_{dl} = A \sqrt{2} \frac{q^2 \epsilon \frac{n_0}{kT}} \cosh\left(\frac{q\psi_{DL}}{2kT}\right)$ where we have replaced the electrode voltage (V_e) by the potential drop (ψ_{dl}) across the electrode. ψ_{DL} must now be obtained by solving for dc operating point of simple voltage divider with C_{layer} and C_{dl} as the two capacitance. By charge conservation,

$$Q_m + Q_{dl} = 0$$

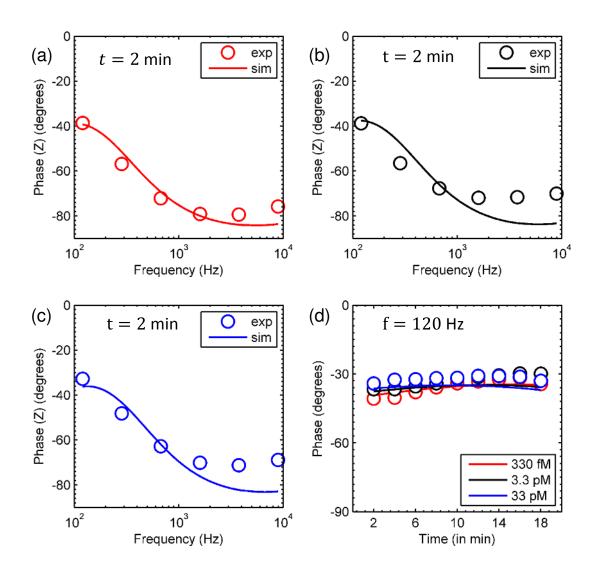
where Q_m is charge on the metal electrode and $Q_{dl} = -\sqrt{8\epsilon_w kT} \, n_0 \sinh\left(\frac{q\psi_{dl}}{2kT}\right)$ is the charge in the double layer. Since; $Q_m = C_{layer} V_{layer} = C_{layer} (V_e - \psi_{dl})$, where V_{layer} is the voltage drop across the dielectric layer. An implicit equation for ψ_{dl} in terms of known variables is obtained which can be solved using any nonlinear equation solver.

S4. Determining the diffusion flux through diffusion equivalent capacitance:

The flux of liquid vapor molecules away from the droplet is given by $\Phi_D = \int_\Omega \vec{J}.\,d\vec{S}$ where $\vec{J} = -D\nabla c$ is the outward flux density at the droplet surface. We need to determine the integral such that $\nabla.\,(\nabla c) = 0$ subject to the boundary condition that surface concentration of the vapors is c_s and that far away from the droplet is c_∞ . This problem is analogous to solving for the electrical charge $Q = \int_\Omega \vec{P}.\,d\vec{S}$ with $\vec{P} = \epsilon \vec{E}$. This can simply be related to the capacitance (C_E) of the system and potential difference between the surface (ψ_s) and far away from the surface (ψ_∞) , *i.e.* $Q = C_E(\psi_s - \psi_\infty)$. From the equivalence between the electrical system and the molecular diffusion system as shown in table below, we arrive at the evaporation flux $\phi_D = C_D(c_s - c_\infty)$.

Electrostatics	Molecular diffusion
ψ	С
ϵ	D
$\nabla.\left(\nabla\psi\right)=0$	$\nabla . \left(\nabla c \right) = 0$
$ec{P}=\epsilonec{E}=-\epsilon abla\psi$	$\vec{J} = -D\nabla c$
$Q = \int_{\Omega} \vec{P} . d\vec{S} = -\int_{\Omega} \epsilon \nabla \psi . d\vec{S} = C_E(\psi_S - \psi_\infty)$	$\Phi_D = \int_{\Omega} \vec{J} \cdot d\vec{S} = -\int_{\Omega} D\nabla c \cdot d\vec{S} = C_e(\phi_s - \phi_\infty)$
$C_E = f(\epsilon)$	$C_D = f(D)$

S5. Verification with experimental data:



SFig. 2 Phase of impedance (calibration curves) vs. frequency at t = 2 min for different DNA concentration (a) 330 fM, (b) 3.3 pM and (c) 33 pM. (d) Phase of impedance vs. Time for different DNA concentration: 330 fM (red), 3.3 pM (black) and 33 pM (blue).

STable 2 : <u>Tables of physical constants</u>

Parameter	Value	Reference
Mobility of <i>Na</i> ⁺ ions in water	$5.1\times10^{-4}cm^2/Vs$	3
Mobility of <i>Cl</i> ⁻ ions in water	$7.6 \times 10^{-4} cm^2/Vs$	3
Mobility of H^+ ions in water	$3.0 \times 10^{-3} \ cm^2/Vs$	3
Mobility of <i>OH</i> ⁻ ions in water	$2.0 \times 10^{-3} \ cm^2/Vs$	3
Permittivity in free space	$8.85 \times 10^{-14} \ F/cm$	4
Relative permittivity of water	78.9	5
Density of water	$1 g/cm^3$	6
Saturation vapor density of water in air at room	$\sim 2.1 \times 10^{-5} \ g/cm^{-3}$	7
temperature		
Diffusion constant for water vapor in air at room	~0.2 cm²/sec	7
temperature		
Humidity factor, $(c_s - c_\infty)/c_s$	0.60	-
Ionic concentration of free H^+/OH^- ions in pure	$10^{-7} M$	-
water		
Thickness of stern layer	0.4 nm	8

STable 3: <u>Table of geometry parameters</u>

Parameter	Value
Electrode width (W)	400 μm
Electrodes separation (L)	20 μm
Length of electrode in contact with solution (H_z)	4 mm
Initial angle of the droplet with the substrate (θ_0)	130°
Droplet contact width (r)	400 μm
Effective area for double layer capacitance (A)	$0.21 \ cm^2$

STable 4: <u>Equations</u>

- Equations		
Time dynamics of droplet evaporat		
$\Phi_m = \int \vec{J} \cdot d\vec{S}$		
	$\vec{J} = -D\vec{\nabla}c$ $\Phi_m = -\frac{dm}{dt} = -P\frac{dV}{dt}$ $V(\theta) = r^2 H_z \left(\frac{\theta}{\sin^2 \theta} - \frac{\cos \theta}{\sin \theta}\right)$	
	$\Phi_m = -\frac{am}{a} = -P\frac{av}{a}$	
	dt dt dt	
1	$V(\theta) = r^2 H_z \left(\frac{\theta}{1 + 2\pi} - \frac{\cos \theta}{1 + 2\pi} \right)$	
	$\sin^2\theta \sin\theta$	
10 00	$R_s(\theta) = r/\sin(\theta)$	
$\frac{d\theta}{dt} = -\frac{D(c_s - c_\infty)}{Pr^2} \frac{(\theta \sin^2 \theta)}{1 - \theta \cot \theta} \left(1 + \frac{0.3069}{\alpha} + \frac{0.2717}{\alpha^2} \right) \frac{1}{\alpha} = -\lambda f(\theta, r, H_z)$		
$dt \qquad Pr^2 \qquad 1 - \theta \cot \theta \qquad \alpha \qquad \alpha^2 \alpha \qquad \alpha^{(0)} \qquad \alpha^{(1)} \qquad \alpha^{(2)} \qquad \alpha^{(2)} \qquad \alpha^{(3)} \qquad \alpha^{(4)} \qquad \alpha^{(4)$		
Geometry dependence of circuit co	mponents	
Series Resistance/Conductance	$1 q(\theta)$	
	$R_{series} = \frac{1}{\sigma} \frac{g(\theta)}{H_z}$	
	$\sigma = q n_i (\mu_p + \mu_n)$	
	$G_{series} = 1/R_{series}$	
	Useries — 1/Nseries	
Double Layer Capacitance	$(1 1)^{-1}$	
	$C_{dl} = \left(\frac{1}{C_0} + \frac{1}{C_{vec}}\right)$	
	$C_{dl} = \left(\frac{1}{C_S} + \frac{1}{C_{diff}}\right)^{-1}$ $C_{diff} = A \sqrt{\frac{2q^2 \epsilon n_i}{kT}} \cosh\left(\frac{qV_e}{2kT}\right)$	
	$c = \sqrt{2q^2 \epsilon n_i} \operatorname{cosh} (qV_e)$	
	$C_{diff} = A \frac{1}{kT} cosn(\frac{1}{2kT})$	
	$A\epsilon_{m}$	
	$C_S = \frac{A\epsilon_w}{d}$	
	uş	
Geometry Capacitance	$C_{geo} = H_z \frac{\epsilon}{a(\theta)}$	
, .	$C_{geo} \equiv H_z \frac{1}{g(\theta)}$	
Time dependence of circuit compo	, +\n	
Series Resistance	$R_{series} = \frac{\left(1 - \frac{t}{T}\right)^{n} g(t)}{\sigma_{0} V_{0} H_{z}}$	
	$R_{series} = \frac{1}{\sigma_0 V_0 H_0}$	
	1 2	
	$G_{series} = \frac{1}{R_{series}}$	
Double Layer Capacitance	$c = (1 t)^{n/2}$	
	$C_{DL} = C_{DL,0} / \left(1 - \frac{t}{T}\right)^{n/2}$	
	$2a^2c^2$	
	$C_{DL,0} = A \sqrt{\frac{2q^2 \epsilon n_0}{kT}} \cosh\left(\frac{qV_e}{kT}\right)$	
	\sqrt{kT}	
Coometry Conseits and	F	
Geometry Capacitance	$C_{geo} = H_z \frac{\epsilon}{g(t)}$	
	$g(\iota)$	

STable 5: Definition of symbols

Net impedance (admittance) of the system	$Z_{net} (Y_{net})$
Droplet impedance (admittance)	$Z_{drop} (Y_{drop})$
Warburg impedance	Z_w
Double layer impedance	Z_{dl}
Parasitic impedance	Z_{par}
Series resistance (conductance)	$R_{series} (G_{series})$
Double layer capacitance	C_{dl}
Differential capacitance	C_{diff}
Stern capacitance	C_S
Stern layer thickness	d_s
Geometry (i.e. dielectric) capacitance	C_{geo}
Charge transfer resistance	R_{ct}
Frequency (Angular Frequency)	f (ω)
Lower and higher cut-off frequencies	f_{low}, f_{high}
Time	t
Sensitivity of the sensor at time <i>t</i>	S(t)
Amplification in sensitivity at time t relative to $t = 0$	$\alpha(t)$
Applied DC bias	V_{dc}
Applied AC bias	V_{ac}
Concentration of chemical/biomolecules	ρ
Initial concentration of ions in the droplet	n_0

Concentration of ions at time t	$n_i(t)$
Width of electrodes	W
Length of electrodes	H_E
Length of cylinderical segment of droplet	H_z
Seperation between electrodes	L
Contact width of droplet	r
Contact angle of drolet with the substrate	θ
Initial volume of droplet	V_0
Volume of droplet at times <i>t</i>	V(t)
Geometry factor at time $t = 0$	g_0
Geometry factor	g(t)
Solution conductivity	σ
Mobility of positive and negative ions	μ_p, μ_n
Diffusion capacitance of truncated cylinder of finite size	C_D
Saturation vapor concentration of liquid	c_s
Diffusion constant for liquid vapors in ambient surroundings	D
Density of the liquid composing the droplet	P

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